




PATENT NUMBER

<p>  </p> <p> O.I.P.E. </p>	<p> PATENT DATE </p>
<p> SCANNED  </p> <p> Q.A.  </p>	

APPLICATION NO. 09/905172	CONT/PRIOR D	CLASS 438	SUBCLASS 710	ART UNIT 1765	EXAMINER <i>WBC</i>
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TITLE  
Etch pattern definition using a CVD organic layer as an anti-reflection coating and hardmask

PTO-2040  
12/96

[illegible]

<input type="checkbox"/> <b>TERMINAL DISCLAIMER</b>	<b>DRAWINGS</b>		<b>CLAIMS ALLOWED</b>	
	Sheets Drwg.	Figs. Drwg.	Print Fig.	Total Claims
<input type="checkbox"/> The term of this patent subsequent to _____ (date) has been disclaimed.	_____ (Assistant Examiner) (Date)		<b>NOTICE OF ALLOWANCE MAILED</b>	
	<input type="checkbox"/> The term of this patent shall not extend beyond the expiration date of U.S. Patent No. _____ _____ _____ (Primary Examiner) (Date)		<b>ISSUE FEE</b> Amount Due Date Paid	
<input type="checkbox"/> The terminal _____ months of this patent have been disclaimed.	_____ (Legal Instruments Examiner) (Date)		<b>ISSUE BATCH NUMBER</b>	
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